EFS ID:	1098800	
Application Number:	10711953	
Confirmation Number:	5952	
Title of Invention:	DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION	
First Named Inventor:	June Cline  30449  Arlen L. olsen/Kimberly Dwileski  Arlen L. olsen	
Customer Number:		
Filer:		
Filer Authorized By:		
Attorney Docket Number:	BUR920040122US1	
Receipt Date:	30-JUN-2006	
Filing Date:	15-OCT-2004	
Time Stamp:	09:42:57	
Application Type:	Utility	

## Payment information:

Submitted with Payment	no
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## File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Applicant summary of interview with examiner	7857interviewsummary.pdf	55209	no	1

Warnings:	
Information:	
Total Files Size (in bytes):	55209

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.